

Information Disclosure Statement Transmittal

I hereby certify that this transmittal of the below described document is being deposited with the United States Postal Service in an envelope bearing First Class Postage and addressed to the Commissioner of Patents and Trademarks, Washington, D.C., 20231, on the below date of deposit.			
Date of Deposit:	July 15, 02	Name of Person Making the Deposit:	Anthony Chou
		Signature of the Person Making the Deposit:	<i>Anthony Chou</i>

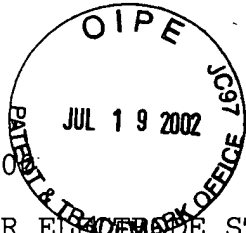
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s): LEE

Serial No.: 09/588,115 Group Art Unit: 2879

Filed: MAY 31, 2002 Examiner: Sikha Roy

Title: MULTI-LAYER ELECTRODE STRUCTURE AND METHOD FOR FORMING
MULTI-LAYER ELECTRODE STRUCTURE FOR A FLAT PANEL DISPLAY
DEVICE



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The Commissioner of Patents and Trademarks
Washington, D.C. 20231
Sir:

Information Disclosure Statement Transmittal

Transmitted herewith is the following:

- Formal drawings, totaling sheets.
- Informal drawings, totaling sheets.
- ☒ Certification for PTO Consideration
- ☒ Information Disclosure statement (2 sheet)
- Information Disclosure statement and late filing fee
- ☒ Form 1449
- Petition for Extension of Time
- Other:

Fee Calculation (for other than a small entity)					
Fee Items				Fee Rate	Total
Petition for Extension of Time (fee calculated elsewhere)				\$.00	
Information Disclosure Statement, late filing				\$240.00	
Other:					
Total Fees					00.00

PAYMENT OF FEES

1. The full fee due in connection with this communication is provided as follows:
 - [X] The Commissioner is hereby authorized to charge any additional fees associated with this communication or credit any overpayment to Deposit Account No.: 23-0085.
A duplicate copy of this authorization is enclosed.
 - [] A check in the amount of \$
 - [X] Charge any fees required or credit any overpayments associated with this filing to Deposit Account No.: 23-0085.

Please direct all correspondence concerning the above-identified application to the following address:

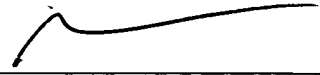
WAGNER, MURABITO & HAO LLP
Two North Market Street, Third Floor
San Jose, California 95113
(408) 938-9060

Respectfully submitted,

Date: _____

2/5/02

By: _____


John P. Wagner, Jr.
Reg. No. 35,398

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Docket No.: CDST-C130.CIP

I hereby certify that this transmittal of the below described document is being deposited with the United States Postal Service in an envelope bearing First Class Postage and addressed to the Assistant Commissioner for Patents, Washington, D.C., 20231, on the below date of deposit.

Date of Deposit:	July 15, 02	Name of Person Making the Deposit:	Anthony Chou	Signature of the Person Making the Deposit:	Anthony Chou
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Inventor(s): LEE

Serial No.: 09/588,115

Group Art Unit: 2879

Filed: MAY 31, 2000

Examiner: Sikha Roy

Title: MULTI-LAYER ELECTRODE STRUCTURE AND METHOD FOR FORMING
MULTI-LAYER ELECTRODE STRUCTURE FOR A FLAT PANEL DISPLAY
DEVICE

The Assistant Commissioner for Patents
Washington, D.C. 20231
Sir:

Certification for PTO Consideration of an Information Disclosure Statement
(Under 37 CFR §1.97)

Consideration of the enclosed Information Disclosure Statement is requested.

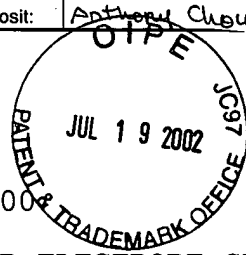
1. This certification is being made for this information disclosure statement
☒ [X] accompanying this certification
☐ [] Filed _____

2. I hereby certify that:

- ☒ [X] Each item of information contained in the information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the statement.
☐ [] No item of information contained in the information disclosure statement was cited in a communication from a foreign patent office in a counterpart application, or, to the knowledge of the person signing certification after making reasonable inquiry, was known to any individual designated in §1.56(c) more than three months prior to the filing of the statement.

3. The person making this certification is

- ☒ [x] a person who is substantively involved in the preparation or prosecution of the application, and who is associated with the inventor, with the assignee, or with anyone to whom there is an obligation to assign the application (37 C.F.R. 1.56 (c)) and who signs below.
- ☐ [] the inventor(s) who signs below
- ☐ [] the practitioner who signs below on the basis of the information:
- ☐ [] supplied by the inventors
 - ☐ [] supplied by an individual designated in § 1.56(c)
 - ☐ [] in the practitioners file



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Please direct all correspondence concerning the above-identified application to the following address:

WAGNER, MURABITO & HAO LLP
Two North Market Street, Third Floor
San Jose, California 95113
(408) 938-9060

Respectfully submitted,

Date: 2/15/02

By: 
John P. Wagner, Jr.
Reg. No. 35,398

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Attorney Docket No.: CDST-C130.CIP



Inventor(s): LEE

Serial No.: 09/588,118

Group Art Unit: 2879

Filed: MAY 31, 2000

Examiner: Sikha Roy

Title: MULTI-LAYER ELECTRODE STRUCTURE AND METHOD FOR FORMING
MULTI-LAYER ELECTRODE STRUCTURE FOR A FLAT PANEL DISPLAY
DEVICE

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The Commissioner of Patents and Trademarks
Washington, D.C. 20231
Sir:

Information Disclosure Statement Submitted Pursuant to 37 C.F.R. 1.97(b)

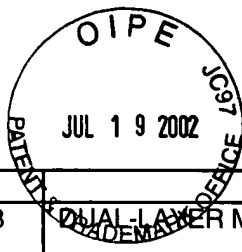
The citations referenced herein, copies attached, may be material to the examination of the above-identified application and are, therefore, submitted in compliance with the duty of disclosure as defined in 37 C.F.R. 1.56. The Examiner is requested to make these citations of official record in the application.

This Information Disclosure Statement submitted in accordance with 37 C.F.R. 1.97(b) is not to be construed as a representation that a search has been made, that additional items material to the examination of this application do not exist, or that any one or more of these citations constitute prior art under 35 U.S.C. 102.

The Examiner's attention is respectfully directed to the following U.S. Patents:

Pat. No. Pat. Title Grant Date

Pat. No.	Pat. Title	Grant Date
4,561,009	SEMICONDUCTOR DEVICE	Dec. 24, 1985
4,940,916	ELECTRON SOURCE WITH MICROPOINT EMISSIVE CATHODES AND DISPLAY MEANS BY CATHODOLUMINESCENCE EXCITED BY FIELD EMISSION USING SAID SOURCE	Jul. 10, 1990
5,090,932	METHOD FOR THE FABRICATION OF FIELD EMISSION TYPE SOURCES, AND APPLICATION THEREOF TO THE MAKING OF ARRAYS OF EMITTERS	Feb. 25, 1992
5,191,217	METHOD AND APPARATUS FOR FIELD EMISSION DEVICE ELECTROSTATIC ELECTRON BEAM FOCUSING	Mar. 2, 1993
5,283,500	FLAT PANEL FIELD EMISSION DISPLAY APPARATUS	Feb. 1, 1994
5,319,279	ARRAY OF FIELD EMISSION CATHODES	Jun. 7, 1994
5,509,839	SOFT LUMINESCENT OF FIELD EMISSION DISPLAY	Apr. 23, 1996
5,866,979	METHOD FOR PREVENTING JUNCTION LEAKAGE IN FIELD EMISSION DISPLAYS	Feb. 2, 1999



Pat. No..	Pat. Title	Grant Date
5,894,188	DUAL-LAYER METAL FOR FLAT PANEL DISPLAY	Apr. 13, 1999
5,594,297	FIELD EMISSION DEVICE METALLIZATION INCLUDING TITANIUM TUNGSTEN AND ALUMINUM	Jan. 14, 1997
6,320,138 B1	SUBSTRATE WITH CONDUCTOR FORMED OF LOW-RESISTANCE ALUMINUM ALLOY	Nov. 20, 2001
6,064,149	FIELD EMISSION DEVICE WITH SILICON-CONTAINING ADHESION LAYER	May 16, 2000
6,019,657	DUAL-LAYER METAL FOR FLAT PANEL DISPLAY	Feb. 1, 2000

Please direct all correspondence concerning the above-identified application to the following address:

WAGNER, MURABITO & HAO LLP
Two North Market Street, Third Floor
San Jose, California 95113
(408) 938-9060

Respectfully submitted,

Date: _____

7/15/02

By: _____

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